

#5/A  
6/18/03  
FAX RECEIVED

**PATENT**

GROUP 1700

JUN 12 2003

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

5    Applicant:            Chih-Ning Wu            Examiner:            Urmez Eronini, Lynette T  
     Filing Date:        07/16/2001            Art Unit:            1765  
     App. No.:            09/682,054            Docket No.:        NAUP0374USA

10    Title:                EXTRUSION-FREE WET CLEANING PROCESS FOR COPPER-DUAL  
                             DAMASCENE STRUCTURES

     To:                Commissioners for Patents  
                             P.O. Box 1450  
                             Alexandria, VA 22313-1450

15    Subject:              Response to the Office action dated 03/14/2003

20

Dear Sir or Madame:

**INTRODUCTORY COMMENTS**

25

     In response to the Office action identified above, the above-identified application is  
to be amended as indicated in the following sections. Consideration of all amendments is  
politely requested.

30